

10/03/03
16085 U.S. PTO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

03945 U.S. PTO
10/678575
100303

In re Application of:	)	CONTINUATION
	)	PATENT APPLICATION
Inventor: Apostolos Voutsas	)	
	)	October 3, 2003
	)	
Serial No.: Unknown	)	Attorney Docket No.
	)	SLA0829 (SLA0590CON)
Filed: Herewith	)	
	)	Parent Application:
Title: SYSTEM AND METHOD	)	
FOR REGULATING	)	Serial No. 09/894,940
LATERAL GROWTH IN	)	Filed: June 28, 2001
LASER IRRADIATED	)	
SILICON FILMS	)	Pending in Group Art
	)	Unit 1765
	)	
	)	Examiner: Robert M.
	)	Kunemund
	)	
Assignee: Sharp Laboratories	)	Anticipated Classification:
of America, Inc.	)	Class: 423
	)	Subclass: 348

**CERTIFICATE OF MAILING BY "EXPRESS MAIL"
UNDER 37 C.F.R. 1.10**

"Express Mail" mailing label number ER501212597US
Date of Mailing: October 3, 2003

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Victoria A. Woods

Victoria Woods

Signature Date: October 3, 2003

CONTINUATION APPLICATION UNDER 37 C.F.R. §1.53(b)

Mail Stop PATENT APPLICATION
Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The undersigned, attorney-of-record in parent application Serial No. 09/894,940, filed June 28, 2001, entitled "System and Method for Regulating Lateral Growth in Laser Irradiated Silicon Films," hereby requests the filing of a Continuation Application under the provisions of 37 C.F.R. §1.53(b).

Identification of the Parent of the Present Continuation Application:

Serial No.: 09/894,940
Filed: June 28, 2001
Title: System and Method for Regulating Lateral Growth
in Laser Irradiated Silicon Films
Inventor: Apostolos Voutsas
Status: Pending

Copy of Present Continuation Application:

Enclosed is a copy of the present continuation application which is a copy of the as-filed specification and drawings in parent application Serial No. 09/894,940 with the following changes: An introductory cross-reference section has been added on page 1, and formal drawings have replaced the as-filed drawings. The present continuation application includes the following papers:

- X No. of Pages in Specification: 36 No. of Claims: 75
X No. of Sheets of Drawings: 6 Formal: X or Informal:
X Copy of the Declaration (signed by all inventors) in parent application Serial No. 09/894,940.
X Copy of the Power of Attorney in parent application Serial No. 09/894,940.

Parent application Serial No. 09/894,940, filed June 28, 2001, entitled "System and Method for Regulating Lateral Growth in Laser Irradiated Silicon Films" is hereby incorporated herein by reference.

Delete the Following Inventor(s) for This Application: None

Amendments:

X Please amend the enclosed specification as follows:

Cancel claims 51-55 and 71-75.

Filing Fee

The Continuation Patent Application filing fee is calculated as shown below after cancellation of claims 51-55 and 71-75:

No. Filed	No. Extra	Rate Small Entity/ Other Than Small Entity	
Basic Fee		\$385.00 \$770.00	\$ 770.00
Total Claims <u>65</u> (<u>20</u>)	= <u>45</u> X	\$ 9.00 \$18.00 =	\$ 810.00
Independent Claims <u>4</u> (<u>3</u>)	= <u>1</u> X	\$43.00 \$86.00 =	\$ 86.00
First Presentation of Multiple Dependent Claim(s) <u>0</u>		\$145.00 \$290.00 =	\$ 00.00
Total PATENT APPLICATION FILING FEE			\$ 1666.00

* If the difference is less than zero, enter "O".

** Count claims after any amendment.

The total fee associated with this communication is as follows:

Patent application filing fee	\$ 1666.00
	=====
TOTAL FEE DUE:	\$ 1666.00

Method of Payment of Fees

- ☐ A check in the amount of the TOTAL FEE DUE is enclosed.
- ☒ Please charge Deposit Account No. 19-1457 in the amount of \$1666.00.
A duplicate copy of this authorization is enclosed.
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Correspondence Address

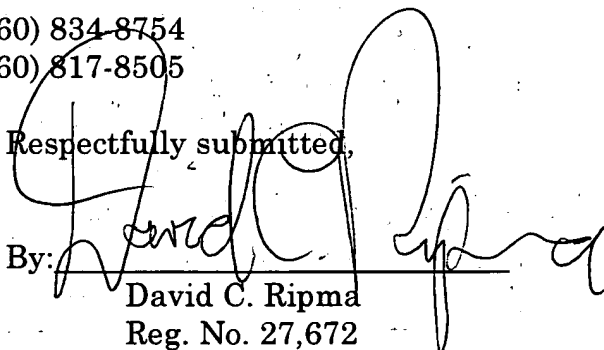
Please direct all correspondence in this application to the following:

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Respectfully submitted,

Date: 10/3/03

By: 

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Reg. No. 27,672

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